

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L3	46	"electrochemical mechanical planarization"	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT	AND	OFF	2005/05/11 15:07
L4	14	L3 and 451/41.ccls.	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT	AND	OFF	2005/05/11 15:07
S1	10	"electrochemical mechanical polishing" slurry with alumina	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT	AND	OFF	2005/05/11 15:06